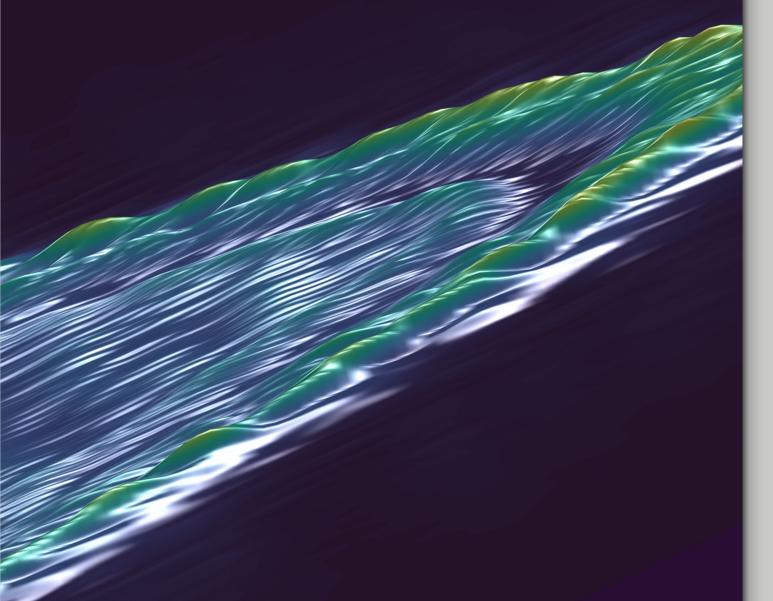
NANOPHOTONICS



Guided Nonlinear Optics for Information Processing





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